

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S59	20	(US-5825647-\$ or US-6263299-\$ or US-6978438-\$ or US-7073162-\$ or US-6226781-\$ or US-6467076-\$ or US-6649309-\$ or US-6301697-\$ or US-6430737-\$ or US-6928634-\$ or US-6813757-\$ or US-6370679-\$ or US-6312854-\$ or US-6120952-\$ or US-6080527-\$ or US-6643616-\$ or US-6033814-\$ or US-6249904-\$ or US-5815685-\$ or US-6269472-\$).did.	USPAT	OR	ON	2007/05/04 22:21
S60	1	S59 AND (control\$1site (control adj site))	USPAT	OR	ON	2007/05/04 22:41
S61	26	("20040088149" "4762396" "5502654" "5655110" "5723233" "5825647" "5879844" "6016357" "6049660" "6077310" "6120952" "6128067" "6187483" "6243855" "6249904" "6263299" "6269472" "6301697" "6370679" "6425117" "6453452" "6453457" "6467076" "6499003" "6643616" "6928634").PN. OR ("7073162").URPN.	USPAT; US-PGPUB; USPAT; USOCR	OR	ON	2007/05/04 22:41
S62	0	S61 AND (control\$1site (control adj site))	USPAT	OR	ON	2007/05/06 17:27
S63	20	(US-5825647-\$ or US-6263299-\$ or US-6978438-\$ or US-7073162-\$ or US-6226781-\$ or US-6467076-\$ or US-6649309-\$ or US-6301697-\$ or US-6430737-\$ or US-6928634-\$ or US-6813757-\$ or US-6370679-\$ or US-6312854-\$ or US-6120952-\$ or US-6080527-\$ or US-6643616-\$ or US-6033814-\$ or US-6249904-\$ or US-5815685-\$ or US-6269472-\$).did.	USPAT	OR	ON	2007/05/06 16:33
S64	3	S63 AND ((parallel co\$1incident coincident) WITH (edge arc))	USPAT	OR	ON	2007/05/06 18:03
S65	6	S63 AND ((edge arc) WITH (curvature (intensity NEAR light)))	USPAT	OR	ON	2007/05/06 17:35
S66	2	S63 AND (control\$1point (control adj point))	USPAT	OR	ON	2007/05/06 17:41
S67	33	("20020199157" "20040005089" "20040088149" "4532650" "4762396" "5502654" "5655110" "5699447" "5723233" "5825647" "5879844" "6016357" "6049660" "6077310" "6120952" "6128067" "6187483" "6243855" "6249904" "6263299" "6269472" "6301697" "6317859" "6370679" "6425117" "6453452" "6453457" "6467076" "6499003" "6665845" "6792159").PN. OR ("6928634").URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2007/05/06 17:35
S68	4	S67 AND ((edge arc) WITH (curvature (intensity NEAR light)))	USPAT	OR	ON	2007/05/06 17:44
S69	1	S68 not S65	USPAT	OR	ON	2007/05/06 17:36
S70	5	S67 AND ((parallel co\$1incident coincident) WITH (edge arc))	USPAT	OR	ON	2007/05/06 17:37
S71	1	S63 AND (dissection\$1point di\$1ssection\$1point evaluation\$1point (dissection adj point) (di\$1ssection adj point) (evaluation adj point))	USPAT	OR	ON	2007/05/06 17:41
S72	66	("5124931" "5206820" "5656402").PN. OR ("5825647").URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2007/05/06 17:44
S73	5	S72 AND ((edge arc) WITH (curvature (intensity NEAR light)))	USPAT	OR	ON	2007/05/06 17:59
S74	47	("5422491" "5561317" "5667923" "5698346" "5700601" "5792581" "5825647").PN. OR ("5991006").URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2007/05/06 17:58
S75	5	S74 AND ((edge arc) WITH (curvature (intensity NEAR light)))	USPAT	OR	ON	2007/05/06 17:59
S76	18	(S72 S74) AND ((parallel co\$1incident coincident) WITH (edge arc))	USPAT	OR	ON	2007/05/06 18:46
S77	0	(S63 S67 S72 S74) AND (tangent WITH (edge arc))	USPAT	OR	ON	2007/05/06 18:49
S78	0	(S63 S67 S72 S74) AND (intensity WITH slope WITH derivative)	USPAT	OR	ON	2007/05/06 19:47
S79	2	(S63 S67 S72 S74) AND (intensity WITH outline)	USPAT	OR	ON	2007/05/06 19:47
S80	4	((("6973633" or ("7155699"))).PN.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/05/06 20:22

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S81	15	((("7178128") or ("6681379") or ("7169515") or ("6457168") or ("7181721") or ("7155699") or ("6301697") or ("6457168") or ("6523165"))).PN.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/05/06 20:47
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IFWsrch_am.txt

<http://www.google.com/>

"Techniques to detect and analyze photomask CD uniformity errors"

"Model-Based OPC Using the MEEF Matrix"

Nicolas Cobb "control site"

Nicolas Cobb "control site" OPC -7073162 -20050097501

"Fast Optical and Process Proximity Correction Algorithms for Integrated Circuit Manufacturing"

"Fast Sparse Aerial Image Calculation for OPC" +pdf OR +ps

"Fast, Low-Complexity Mask Design,"

"Fast Sparse Aerial Image Calculation for OPC"

"Large Area Phase-Shift Mask Design"

"Using OPC to Optimize for Image Slope and Improve Process Window"

"Generalized MEEF Theory"

"MEEF as a Matrix,"

"Two-Dimensional G-MEEF Theory and Applications,"

"Process Proximity Correction Using an Automated Software Tool,"

"Evaluation of a Fast and Flexible OPC Package: OPTISSIMO,"

"Lithography Computer Aided Design Technology for Embedded Memory in Logic,"